

ABSTRACT

To provide a purge stocker and a purging method allowing a simple configuration of the device while reducing the consumption of the purge gas. A purge stocker 1 includes a first supply unit 20 including N first purge apparatuses 21 each having a first supply unit 22 configured to support a storage container F, a first supply pipe 23 configured to supply the purge gas into the storage container F supported by the first supporting unit 22, and a first flow rate adjusting unit 24 configured to adjust the flow rate of the purge gas in the first supply pipe 23; and a second supply unit 30 including M second purge apparatuses 31 each having a second supporting unit 32 configured to support the storage container F and a second supply pipe 34 configured to supply the purge gas into the storage container F supported by the second supporting unit 32. When the storage containers F are supported by a certain number of second supporting units 32, the second supply unit 30 supplies the storage containers F with the purge gas through the respective second supply pipes 34.